Docket No. 220033US90

IN RE APPLICATION OF: Fuyuhiko INOUE, et al.

SERIAL NO: 10/080,537 RCE FILED: June 21, 2004

FOR: WAVEFRON

WAVEFRONT ABERRATION MEASURING METHOD AND UNIT, EXPOSURE APPARATUS, DEVICE

1514.

MANUFACTURING METHOD, AND DEVICE

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR

Transmitted herewith is a SUPPLEMENTAL AMENDMENT in the above-identified application.

No	additional	fee	is	req	uire	d
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- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	31	MINUS	31	0	х	\$18	=	\$0.00
INDEPENDENT	4	MINUS	4	0	х	\$86	=	\$0.00
		☐ MULTIPI	E DEPENDENT	CLAIMS	+	\$290	=	\$0.00
	•		TOTAL	OF ABOVE CA	ALC	JĻATIO	ONS	\$0.00
		☐ Reduction	by 50% for filing	by Small Entity	,			\$0.00
		☐ Recordation	on of Assignment		+	\$40	=	\$0.00
						TO	ΓAL	\$0.00

\square A check in the amount of \$0.00 is attac
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- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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Christopher D. Ward Registration No. 41,367 DOCKET NO: 220033US90

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Fuyuhiko INOUE, et al.

: EXAMINER: STAFIRA, M. P.

SERIAL NO.: 10/080,537

RCE FILED: June 21, 2004

: GROUP ART UNIT: 2877

FOR: WAVEFRONT ABERRATION

MEASURING METHOD AND

UNIT, EXPOSURE APPARATUS, DEVICE **MANUFACTURING** METHOD, AND DEVICE

SUPPLEMENTAL AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Supplemental to the Amendment filed on June 21, 2004, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks/Arguments begin on page 19 of this paper.